IN THE CLAIMS

- 1. (Currently amended) A method for preparing an organic silicate polymer, comprising:
- i) mixing-silane compound with organic-solvent-to-form a first mixture, the silane compound being one selected from the group consisting of:
 - b) cyclic siloxane represented by the following Chemical Formula 3,

and

- d) a mixture of the cyclic siloxane represented by the Chemical Formula 3 and silane or silane oligomer represented by the following Chemical Formula 4 or Chemical Formula 5, respectively; and
 - ii) hydrolyzing and condensing the first-mixture by adding water and catalyst;

Chemical-Formula-3

wherein:

R² is hydrogen, fluorine, aryl, vinyl, allyl, or linear or branched C₁₋₄ alkyl substituted or unsubstituted with fluorine;

R⁺is hydrogen or linear or branched C₁₋₁alkyl;

x and y are independently an integer of 3 to 10, and

(2y-x) is an integer of 1 to 17;

Chemical Formula-4

SiR PR LP

wherein:

R^s-is hydrogen, aryl, vinyl, allyl, or linear or branched C₁₋₁alkyl substituted or unsubstituted with fluorine;

R⁶ is acetoxy, hydroxy, or linear or branched C₁₋₄ alkoxy; and

P is independently an integer of 0 to 2;

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Chemical Formula 5

R3 R8 2 Si-M-SiR4 R10 3+

wherein:

R² and R⁴ are hydrogen, aryl, vinyl, allyl, or linear or branched C₁₋₁ alkyl substituted or unsubstituted with fluorine, respectively;

 $R^{*} and \ R^{*0} are \ acctoxy, \ hydroxy, \ or \ linear \ or \ branched \ C_{L4} \ alkoxy, \ respectively;$

M is C_{1.6} alkylene or phenylene; and

q and r are independently an integer of 0 to 2. oxidizing hydrosilane oligomer represented by the following Chemical Formula 1 or cyclic hydrosilane oligomer represented by the following Chemical Formula 2 in the presence of water or alcohol to prepare siloxane oligomer;

mixing the siloxane oligomer or a mixture of the siloxane oligomer and silane or silane oligomer represented by the following Chemical Formula 4 or Chemical Formula 5, respectively, with organic solvent to form a first mixture; and

hydrolyzing and condensing the first mixture by adding water and catalyst:

Chemical Formula 1

 $R^1 Si(OSi)_m H_{(2m-n+4)}$

wherein:

R¹ is hydrogen, fluorine, aryl, vinyl, allyl, or linear or branched C₁₋₄ alkyl substituted or unsubstituted with fluorine;

m is an integer of 1 to 20;

n is an integer of 1 to 20, and

(2m-n+4) is an integer of 1 to 43;

Chemical Formula 2

$$H_k \square_{SiO} (R^2)_{21-k}$$

wherein:

 R^2 is hydrogen, fluorine, aryl, vinyl, allyl, or linear or branched C_{1-4} alkyl substituted or unsubstituted with fluorine;

k and lare integers of 3 to 10, and

(21-k) is an integer of 1 to 17;

Chemical Formula 4

 $SiR^{5}pR^{6}_{4-p}$

wherein:

 R^5 is hydrogen, aryl, vinyl, allyl, or linear or branched C_{1-4} alkyl substituted or unsubstituted with fluorine;

R⁶ is acetoxy, hydroxy, or linear or branched C₁₋₄ alkoxy; and

P is an integer of 0 to 2;

Chemical Formula 5

 $\frac{R^{7}}{9}R^{8}_{3-9}Si-M-SiR^{9}_{r}R^{10}_{3-r}$

wherein:

R⁷ and R⁹ are hydrogen, aryl, vinyl, allyl, or linear or branched C₁₋₄ alkyl substituted or unsubstituted with fluorine, respectively;

 R^8 and R^{10} are acetoxy, hydroxy, or linear or branched C_{1-4} alkoxy, respectively;

M is C₁₋₆ alkylene or phenylene; and

q and r integers of 0 to 2.

2. - 5. (Canceled)

- 6. (Currently Amended) The method according to Claim 1, wherein the silane or silane oligomer represented by Chemical Formula 4 or Chemical Formula 5 of e) and d) comprises silicon, oxygen, carbon and hydrogen.
 - 7. (Canceled).
- 8. (Original) The method according to Claim 1, wherein an amount of the catalyst is between about 0.000001 mol to about 2 mol, based on about 1 mol of the silane compound.

- 9. (Previously presented) The method according to Claim 1, wherein hydrolyzing and condensing the first mixture are performed at a temperature of about 15°C to about 80°C.
 - 10. (Withdrawn) An organic silicate polymer prepared by the method of Claim 1.
- 11. (Withdrawn) A composition for forming an insulation film of a semiconductor device, comprising:

organic silicate polymer and organic solvent,

the organic silicate polymer being prepared by mixing silane compound with the organic solvent to prepare a first mixture and hydrolyzing and condensing the first mixture by adding water and catalyst, the silane compound being selected from a group consisting of:

- i) oxidized hydrosilane;
- ii) cyclic siloxane;
- iii) a second mixture of oxidized hydrosilane and silane or silane oligomer; and
 - iv) a third mixture of cyclic siloxane and silane or silane oligomer.
- 12. (Withdrawn) The composition for forming an insulation film according to Claim 11, further comprising one or more additives selected from a group consisting of organic molecules, organic polymers, organic dendrimers, pH adjuster, colloidal organic silica and surfactant.
- 13. (Withdrawn) A method for preparing an insulation film of a semiconductor device, comprising:
- a) mixing silane compound with organic solvent to prepare a first mixture and hydrolyzing and condensing the first mixture by adding water and catalyst to obtain an organic silicate polymer, the silane compound being selected from a group consisting of:
 - i) oxidized hydrosilane;
 - ii) cyclic siloxane; P20042543US

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- iii) a second mixture of oxidized hydrosilane and silane or silane oligomer; and
- iv) a third mixture of cyclic siloxane and silane or silane oligomer;
- b) dissolving the organic silicate polymer in solvent;
- c) coating the dissolved organic silicate polymer on a substrate of a semiconductor device; and
 - d) dying and hardening the coated insulation film.
- 14. (Withdrawn previously presented) The method according to Claim 13, wherein coating the dissolved organic silicate polymer is performed by a spin coating, a dipping, a roll coating or a spraying.
- 15. (Withdrawn previously presented) The method according to Claim 13, wherein drying the coated insulation film is carried out at a temperature of about 30°C to about 350°C, and hardening the coated insulation film is carried out at a temperature of about 350°C to about 500°C.
- 16. (Withdrawn) An insulation film of a semiconductor device prepared by the method of Claim 13.
- 17. (Withdrawn) The insulation film according to Claim 16, wherein the insulation film has a thickness of about $0.05\mu m$ to about $2\mu m$.
- 18. (Withdrawn) A semiconductor device that comprises the insulation film prepared by the method of Claim 13.
 - 19. and 20. (Canceled).

21. (Canceled)

22. (Currently Amended) The method according to Claim [[21]], wherein oxidizing the hydrosilane oligomer or cyclic oligomer is carried out by adding at least one <u>catalyst</u> or a peroxide oxidizing agent, the catalyst being selected from the group consisting of Pd, Pt and Rh.